

**LIST OF PRIOR ART
CITED BY APPLICANT**

(Use several sheets if necessary)

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Applicant
Nancy A. Greco, et al.

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Filing Date
~~Herewith~~ 9/9/03

Group
~~Classified~~ 2813

U.S. PATENT DOCUMENTS

EXAMINER INITIAL*		DOCUMENT NUMBER	DATE	NAME	CLASS	SUBCLASS	FILING DATE (if appropriate)
JMS	AA	5,436,477	7/1995	Hashizume et al.			
JMS	AB	5,366,920	1/1994	Yamamichi et al.			
JMS		5,440,174	8/8/1995	Nishitsuji			
JMS		5,068,694	11/26/1991	Ohara			
JMS		4,786,612	11/22/1988	Yau et al.			
JMS		4,335,504	6/22/1982	Shibata et al.			
JMS		4,897,153	1/1990	Cole et al.			
JMS		5,736,448	4/1998	Saia et al.			
JMS		5,708,559	1/1998	Brabazon et al.			
JMS		5,407,861	4/1995	Marangon et al.			
JMS		5,258,096	11/1993	Papu D. Maniar			
JMS		5,407,855	4/1995	Maniar et al.			
JMS		5,566,045	10/1996	Summerfelt et al.			
JMS		5,625,232	4/1997	Numata et al.			

FOREIGN PATENT DOCUMENTS

		DOCUMENT NUMBER	DATE	COUNTRY	CLASS	SUBCLASS	TRANSLATION	
							YES	NO
JMS		06140737	5/1994	JAPAN				
JMS		05299601	11/1993	JAPAN				
JMS		0750354	12/1996	JAPAN				

OTHER PRIOR ART (Including Author, Title, Date, Pertinent Pages, Etc.)

JMS		James McCreary, "Matching Properties and Voltage and Temperature Dependence of MOS Capacitors", IEEE Journal of Solid-State Circuits, December 1981, pp. 608-616, Vol. SC-16, No. 6; and
JMS		K. Machida et al., "Metal-insulator-Metal Capacitors by Using Electron Cyclotron Resonance Plasma-SiO ₂ ", Journal Vacuum Science Technology, B, 13(5), pp. 2013-2015, September/October 1995.

EXAMINER *[Signature]*

DATE CONSIDERED 11/10/04

* EXAMINER: Initial if reference considered, whether or not citation is in conformance with MPEP 609; draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.